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TC 2800 MAIL ROOM
PATENT APPLICATION
Do. No. 5484-48

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup SHIM et al.

Serial No. 09/305,240

Examiner: Nadav, O.

Filed: May 4, 1999

Group Art Unit: 2811

For: **OPEN DRAIN INPUT/OUTPUT STRUCTURE AND MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR DEVICE**

Date: June 6, 2001

BOX NON FEE AMENDMENT
Assistant Commissioner for Patents
Washington, D.C. 20231

#13
Response
FJONGS
6-19-01

RESPONSE TO OFFICE ACTION

Responsive to the Office Action, dated March 14, 2001, Applicant makes the following:

REMARKS

Prior to this Response, an Office Action was issued, mailed March 14, 2001.

In the Office Action, claims 5-7 and 9 were rejected.

Claims 5-7 and 9 are still pending in the present application. Reconsideration is requested in view of the following:

* **The rejection of the claims:**

Claims 5-7 and 9 remain rejected under 35 U.S.C. 103(a) as being unpatentable over MacDougall et al. (3,895,966) in view of Admitted Prior Art (APA).

The rejection is respectfully traversed.

The invention has a feature that is neither taught nor suggested in either one of the prior art references. Novel features are unobvious under 103(a). The novel feature of claim 5 is: